

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2814**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Application No.: 08/930,449

Filed: September 30, 1997

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF
FORMING CRYSTALLINE FILM AND METHOD OF
MANUFACTURING THIN FILM ELECTRONIC DEVICE

Group Art Unit: 2814

Examiner: S. Rao

Docket No.: JAO 39514

REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In response to the final Office Action mailed April 11, 2000, Applicants respectfully
request reconsideration and allowance in view of the following remarks.

Claims 1, 2 and 4-63 are pending. Claims 19, 24, 29, 34, 39, 44, 45 and 50-55 have been
withdrawn from consideration.

Rejections Under 35 U.S.C. §103

1. The Office Action rejects claims 1, 2, 4-18, 20-23, 25-28, 30-33, 35-38, 40-43 and 63
under 35 U.S.C. §103(a) over Zhang et al. (U.S. Patent No. 5,403,772) in view of Nakamura
(U.S. Patent No. 5,200,630). Applicants respectfully traverse this rejection.

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